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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet 1 of 4

Complete If Known

Application Number	10/047,454
Filing Date	January 14, 2002
First Named Inventor	Victor B. Kley
Art Unit	2878
Examiner Name	Thanh X Luu
Attorney Docket Number	020921-001110US

U.S. PATENT DOCUMENTS+

Examiner Initials*	Cite No. ¹	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
DXL	1	6,353,219	03-05-2002	Kley	
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Examiner Name	Thanh X Luu

Attorney Docket Number 020921-001110US

U.S. PATENT DOCUMENTS+

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		Country Code ³	Number ⁴ Kind Code ⁵ (if known)				
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Filing Date	January 14, 2002
First Named Inventor	Victor B. Kley
Art Unit	2878
Examiner Name	Thanh X Luu
Attorney Docket Number	020921-001110US

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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